### **Fusion Science and Technology Studies using the Basic Plasma Science Facility**

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### Summary

- Basic Plasma Science Facility: US DOE and NSF sponsored collaborative research facility for study of fundamental processes in magnetized plasmas. Primary device is Large Plasma Device (LAPD).
- Wide range of studies performed: waves, instabilities, turbulence & transport, shocks, reconnection. Will cover recent work relevant to fusion science and technology:
  - **ICRF Campaign**: Mitigation of RF sheaths using insulating antenna enclosure [Bal et al., NF (2022)], parasitic coupling to slow mode, HHFW/Helicon wave coupling and propagation
  - **Plasma-materials interaction studies:** Testing novel materials (VCMs) in LAPD: significantly decreased arcing/sputtering in VCM versus flat W targets

### The Large Plasma Device (LAPD): a flexible experimental platform



- 20m long, 1m diameter vacuum chamber; emissive cathode discharge
- LaB<sub>6</sub> Cathode: n ~ 1x10<sup>13</sup> cm<sup>-3</sup>, T<sub>e</sub> ~ 10–15 eV, T<sub>i</sub> ~ 6–10 eV
- B up to 3.5kG (with control of axial field profile)
- High repetition rate: 1 Hz
- US DOE & NSF Sponsored Collaborative Research Facility (international users welcome!)



# Plasma Source Upgrade: large-area LaB<sub>6</sub>



- New large-area LaB<sub>6</sub> emissive cathode source provides higher power density; access to higher density, higher pressure plasmas
- New magnet section, up to 0.9T, to allow magnetic expansion of plasma source region
- Additionally, installed capability for gas-puffing to fuel discharge to access improved operational regimes



Y. Chen, et al., Rev Sci Instrum., 94, 085104 (2023)





# ICRF Physics and Technology Studies on LAPD

- Studies of Ion Cyclotron Range of Frequencies (ICRF) waves used to heat ions and electrons and drive current in fusion experiments
- Campaign participation from scientists & engineers at ORNL, MIT, PPPL, General Atomics, TAE Technologies, ASIPP, Max Planck IPP, U. Ghent...
  - Parasitic processes and their mitigation: **RF sheaths, coupling to slow mode**, parametric instabilities.
  - Helicon waves: studying wave coupling and n control with DIII-D **low-power Helicon antenna**
  - Mirror relevant studies: cyclotron absorption of shear waves in strong magnetic field gradients ("magnetic beach" geometry)

# Infrastructure for exciting shear, fast, Helicon waves





Single-strap ICRF insertable, rotatable







- Multiple high and low-power antennas available
- High power triode source: ~2.5MHz, f=1-10 fci, ~200 kW
- High power solid state sources: up to 1MHz, ~100kW+
- Low power (~400W) sources up to 600MHz+



### Large amplitude fast waves excited using single-strap antenna



- High power (triode) source: f=1-10 fci, ~200 kW
- Coupled fast wave: m=1 mode structure observed

### magnetic fluctuations



# 3D wave measurements: m=1 fast wave eigenmode excited by single-strap antenna





### Plasma potential measurements show evidence of RF rectification



# LaB<sub>6</sub> Limiter, z = -3.9 m LaB<sub>s</sub> Plasma **BaO Plasma** t (not to scale) LaB<sub>6</sub> Discharge Circuit 10.2 10.0 10.4

# **2D Potential measurements: Near-field RF** sheaths localized on antenna structure

Before RF

During RF



Martin, et al. PRL 119, 205002 (2017)

# Impacts of RF Sheaths: sputtering and density modification









• Copper coatings on probes following high-power RF run: sputtering from copper antenna enclosure





Vectors: ExB flow, deduced from V<sub>p</sub>

# Insulating antenna sidewalls mitigate RF sheath



# Mitigation consistent with model predictions



- Myra/D'Ippolito model: Insulator effectively forms voltage divider with plasma sheath. RF Sheath mitigation when insulator impedance is much larger than plasma sheath impedance
- Increased RF rectification seen in lower-density plasmas, consistent with model

# Parasitic coupling to slow mode in LAPD

If density at antenna is low enough, unwanted coupling to slow mode (LH wave) is possible, leading to lost power, far-field sheaths, etc.



# Parasitic coupling to slow mode observed in low density plasma near antenna

Lower hybrid wave near antenna, backward propagation

Fast wave in high density core plasma, m = 1 mode as before



Radial position of antenna aperture

### G. Bal, B. Van Compernolle, et al. in prep.

# Helicon wave studies on LAPD using DIII-D prototype antenna



- Helicon antenna designed to launch fast waves in lower hybrid range of frequencies for off-axis current drive in DIII-D; low power prototype antenna installed in LAPD
- Operating at ~500MHz, can couple to both Fast Wave and Slow Wave in LAPD density/magnetic field conditions

ne [cm-3]

# Coupling/Propagation observed in expected density regimes



 Propagation in low-density edge during "main phase", penetrates into core as density drops during afterglow

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### Coupling to both fast wave and slow wave observed Antenna at x,z = (-30,0) cm



t = 27 ms

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 $\mathcal{V}_{\phi}$ 



t = 27 ms

 $\overline{v}_{\phi}$ 

# Ongoing work: wave interaction with turbulence, scattering, mode conversion to SW





- In presence of drift-wave turbulence, see spectral broadening, wave power confined to edge region
- Possible scattering/mode conversion by turbulent filaments? (C. Lau et al., NF 2021, W. Tierens PoP 2020)



# Tests of Volumetrically Complex Materials (VCMs) as PFCs/ Electrodes in LAPD



- D Ligament Circular Pores
- VCMs including metal foams: reduction in sputtering/secondary emission via geometric trapping & recapturing



- Additional improvements from "plasma infusion" of the material
- Testing of sputtering/arcing performance via plasma exposure/biasing in LAPD













### VCM have lower sputtering, mitigate arc impacts in LAPD tests



• Fast framing camera imaging: saw far fewer arcs, more arc movement on surface, and less sputtering with VCM (W Foam) compared to flat W target

A. Ottaviano, et al., in prep

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